

**Application Data Sheet**

**Application Information**

Application Number::

Filing Date::

Application Type::

Subject Matter::

Suggested Classification::

Suggested Group Art Unit::

Title::

Attorney Docket Number::

Request for Early Publication::

Request for Non-Publication::

Suggested Drawing Figure::

Total Drawing Sheets::

**International Application No.**

**PCT/JP2004/012775**

**PCT filed on August 27, 2004**

**U.S. filing on February 27, 2006**

**US National Phase**

**Utility**

**FILM OF SP<sup>3</sup>-BONDED BORON NITRIDE  
HAVING A SELF-ORGANIZED SURFACE  
TEXTURE CAPABLE OF PROMOTING FIELD  
ELECTRON EMISSION, METHOD FOR  
PRODUCING THE SAME AND USE THEREOF  
TCP-005**

**5**

322569545  
JAP2004-012775 27 FEB 2006

## **Applicant Information**

Applicant Authority Type::	<b>Inventor</b>
Primary Citizenship Country::	<b>Japanese</b>
Status::	<b>Full capacity</b>
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## Correspondence Information

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## Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
<b>This Application</b>	<b>US National Stage</b>	<b>PCT/JP2004/012775</b>	<b>August 27, 2004</b>

## Foreign Priority Information

Country::	Application Number::	Filing Date::	Priority Claimed::
<b>JAPAN</b>	<b>2003-209489</b>	<b>August 29, 2003</b>	<b>Yes</b>

## Assignee Information

Assignee Name:: **NATIONAL INSTITUTE FOR MATERIALS  
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